



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Yeo, *et al.* Docket No.: TSM03-0421  
Serial No.: 10/608,287 Art Unit: 2891  
Filed: June 27, 2003 Examiner: Chaudhari, Chandra P.  
For: Structure and Method for Forming the Gate Electrode in a Multiple-Gate Transistor

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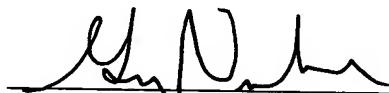
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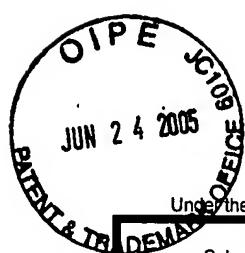
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Sheet 1 of 4 Attorney Docket Number TSM03-0421

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## U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code <sup>2</sup> (if known)			
	1	US-4,933,298	06-12-1990	Hasegawa	
	2	US-4,946,799	08-07-1990	Blake et al.	
	3	US-5,317,175	05-31-1994	Throngnumachai	
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	5	US-5,464,783	11-07-1995	Kim et al.	
	6	US-5,607,865	03-04-1997	Choi et al.	
	7	US-5,814,895	09-29-1998	Hirayama	
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## FOREIGN PATENT DOCUMENTS

Examiner Signature		Date Considered	
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4

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Application Number	10/608,287
Filing Date	June 27, 2003
First Named Inventor	Yeo, et al.
Art Unit	2891
Examiner Name	Chaudhari, Chandra P.
Attorney Docket Number	TSM03-0421

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		Number - Kind Code <sup>2</sup> (if known)			
	23	US-6,475,890 B1	11-05-2002	Yu	
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				Application Number	10/608,287
				Filing Date	June 27, 2003
				First Named Inventor	Yeo, et al.
				Art Unit	2891
				Examiner Name	Chaudhari, Chandra P.
<i>(Use as many sheets as necessary)</i>					
Sheet	3	of	4	Attorney Docket Number	TSM03-0421

<b>NON PATENT LITERATURE DOCUMENTS</b>				
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		T <sup>2</sup>
	48	AUTH, C.P., et al., "Scaling Theory for Cylindrical, Fully-Depleted, Surrounding-Gate MOSFET's," IEEE Electron Device Letters, Vol. 18, No. 2 (February 1997) pp. 74-76.		
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<i>Filing Date</i>	June 27, 2003
<i>First Named Inventor</i>	Yeo, et al.
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